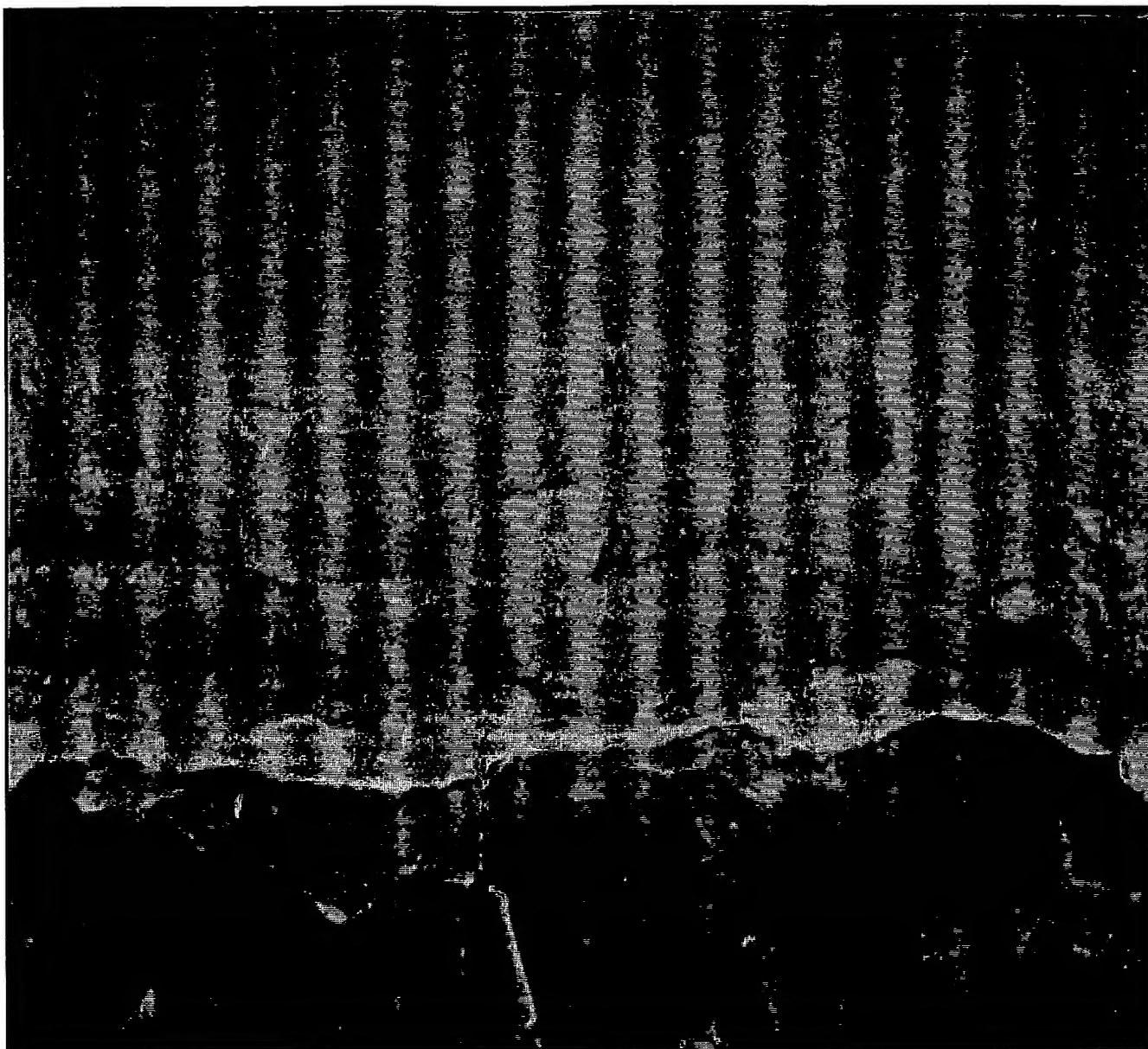


Dielectric layers formed by MOD process



Dielectric layer formed by sputtering process

